

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:	)	
	)	
Liang, Ted et al.	)	
	)	
U.S. Serial No: 09/895,511	)	Examiner: Zervigon, Rudy
	)	
Filed: June 29, 2001	)	Art Unit: 1763
	)	
For: APPARATUS FOR ELECTRON	)	
BEAM-INDUCED CHEMICAL	)	
ETCHING	)	

Mail Stop Amendment  
Commissioner for Patents  
P. O. 1450  
Alexandria, VA 22313-1450

**AMENDMENT AND RESPONSE**

Dear Sir:

This is in response to the Office Action mailed on April 24, 2006. Applicants respectfully request the Examiner to enter the following amendments and consider the following remarks.